

Electronic Patent Application Fee Transmittal

Application Number:	10539886			
Filing Date:	17-Jun-2005			
Title of Invention:	Method for preparing film structure comprising ferroelectric single crystal layer			
First Named Inventor/Applicant Name:	Jaehwan Eun			
Filer:	Eugene Lieberstein/Audrey de Souza			
Attorney Docket Number:	DE1643			
Filed as Small Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	2801	1	405	405
Total in USD (\$)				405